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CONFIRMATION NO. 7748

SERIAL NUMBER 10/706,902	FILING DATE 11/12/2003 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. AMAT/8501/ETCH/DRIE/JB
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APPLICANTS

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** CONTINUING DATA *****

This appln claims benefit of 60/493,824 08/08/2003

BT

** FOREIGN APPLICATIONS *****

None BT

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 02/06/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <u>Binh Tran</u> Examiner's Signature Initials	STATE OR COUNTRY CA	SHEETS DRAWING 6	TOTAL CLAIMS 40	INDEPENDENT CLAIMS 3
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ADDRESS

55649
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TITLE

Selective etch process of a sacrificial light absorbing material (SLAM) over a dielectric material

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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